**BMEN6381 - Advanced Concepts in Microscopy**

*Bemen 6381 (EEBM 6381)* Advanced Concepts in Microscopy (3 semester credit hours) Continuation of *BMEN 6380*, with emphasis on advanced approaches such as vectorial diffraction, stochastic aspects of image formation and analysis. Prerequisite: *BMEN 6380* or *EEBM 6380* or instructor consent required. (3-0) R